

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re application of | |) |
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| | Tetsuro Inui et al. |) |
| | |) |
| Serial No.: | 10/624,082 |) Art Unit |
| | |) 2613 |
| Filing Date: | July 21, 2003 |) |
| | |) |
| Confirmation No.: | 5995 |) |
| | |) |
| For: | DISPERSION MONITORING METHOD AND |) |
| | APPARATUS AND DISPERSION SLOPE |) |
| | TEMPERATURE DEPENDENCY COMPENSATION |) |
| | METHOD AND APPARATUS |) |
| | |) |
| Examiner: | Hibret Asnake Woldekidan |) |

AMENDMENT "D" AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Examiner:

Applicant submits this paper in response to the Office Action mailed July 23, 2009.
Reconsideration is respectfully requested in view of the following remarks:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.